



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

Report verification at [igi.org](https://www.igi.org)

July 17, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG819647389

LABORATORY GROWN DIAMOND

ROUND BRILLIANT

7.30 - 7.33 X 4.55 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

Cut Grade

1.51 CARAT

D

VVS 2

IDEAL

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

EXCELLENT

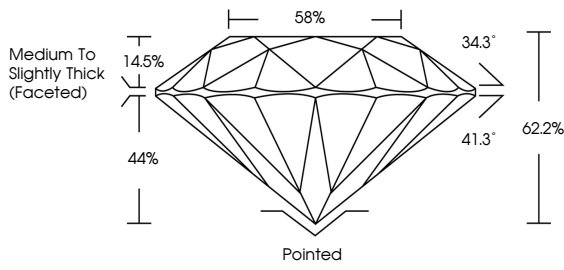
NONE

 LG819647389

Comments: HEARTS & ARROWS

This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Medium To Slightly Thick (Faceted)

58%

34.3°

41.3°

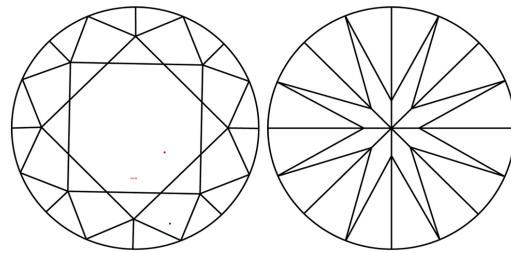
62.2%

44%

14.5%

Pointed

CLARITY CHARACTERISTICS



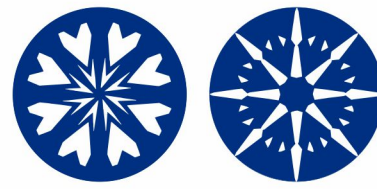
KEY TO SYMBOLS



Red symbols indicate internal characteristics.



Green symbols indicate external characteristics.





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Inscription(s)

EXCELLENT

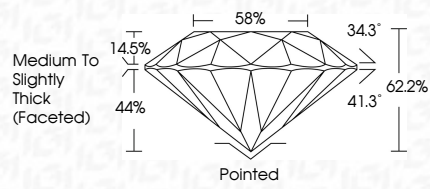
EXCELLENT

NONE

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34.3°

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Pointed





July 17, 2026

IGI Report No LG819647389

ROUND BRILLIANT

7.30 - 7.33 X 4.55 MM

Carat Weight

Color Grade

Clarity Grade

Cut Grade

Depth

Table

Girdle

Medium To Slightly Thick (Faceted)

Pointed

Polish

Symmetry

Fluorescence

Inscription(s)

1.51 CARAT

D

VVS 2

IDEAL

62.2%

88%

None

EXCELLENT

EXCELLENT

NONE

 LG819647389

Comments: HEARTS & ARROWS

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